

1960.30 DIV. I

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
TIMOTHY M. RICHARDSON ) : Examiner: R. Ratliff  
Application No.: NYA ) : Group Art Unit: 2877  
Filed: February 2, 2001 ) :  
For: TEST SLIDE FOR ) February 2, 2001  
MICROSCOPES AND METHOD ) :  
FOR THE PRODUCTION OF ) :  
SUCH A SLIDE ) :

jc841 U.S. PTO  
09/773674  
02/02/01



Commissioner for Patents  
Washington, D.C. 20231

[This application is a divisional of  
Appln. No. 08/882,491, filed  
June 25, 1997, now allowed]

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under  
37 C.F.R. § 1.56 and in accordance with the practice under  
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is  
directed to the documents listed on the enclosed Form  
PTO-1449. Copies of the listed documents are also enclosed.

CONCLUSION

It is respectfully requested that the below-listed information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 625-3500. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicant  
Registration No. 31,588

PATENT ADMINISTRATOR  
KATTEN MUCHIN ZAVIS  
525 West Monroe Street  
Suite 1600  
Chicago, Illinois 60661-3693  
Facsimile: (312) 902-1061

Date Submitted to PTO: **February 2, 2001**ATTY DOCKET NO.  
**1960.30 DIV. I**APPLICATION NO.  
**NYA**APPLICANT  
**TIMOTHY M. RICHARDSONI**FILING DATE  
**February 2, 2001**GROUP  
**2877**U.S. PTO  
1C841 U.S. PTO  
09/73674  
02/02/01

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLAS S	FILING DATE IF APPROPRIATE
	<b>4,055,376</b>	<b>10/77</b>	<b>Daberko</b>	<b>350</b>	<b>10</b>	
	<b>5,622,796</b>	<b>4/97</b>	<b>Canestrari, et al.</b>	<b>430</b>	<b>22</b>	
	<b>4,616,241</b>	<b>10/86</b>	<b>Biefeld, et al.</b>	<b>357</b>	<b>16</b>	
	<b>4,947,223</b>	<b>8/90</b>	<b>Biefeld, et al.</b>	<b>357</b>	<b>30</b>	
	<b>5,027,178</b>	<b>6/91</b>	<b>Svilans</b>	<b>357</b>	<b>30</b>	
	<b>5,608,519</b>	<b>3/97</b>	<b>Gourley, et al.</b>	<b>356</b>	<b>318</b>	

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES/NO/ OR ABSTRACT
	<b>0,214,1601</b>	<b>5/90</b>	<b>Europe</b>	<b>G01B</b>	<b>7/34</b>	<b>Abstract</b>
	<b>2,702,277</b>	<b>9/94</b>	<b>France</b>	<b>G01M</b>	<b>11/00</b>	

## OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 2

Date Submitted to PTO: **February 2, 2001**ATTY DOCKET NO.  
**1960.30 DIV. I**APPLICATION NO.  
**NYA**APPLICANT  
**TIMOTHY M. RICHARDSONI**FILING DATE  
**February 2, 2001**GROUP  
**2877**

PTO

1C841 U.S. 3674  
11/09/01 02/01

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

**Electro-Optical Systems Design; OTF Quantitative Image Analysis; David Smith, Dec. 1979.****Cambridge University Press; Nanofabrication And Biosystems, H. Hoch, L.W. Jelinski, and H.G. Craighead.****Development In Semiconductor Microlithography; Testing The Mann Type 4800DSW™ Wafer Stepper™, W. Schneider, vol. 174, pp. 6-14 (1979)****JENOPTIK, Laser Optik Systeme****“Contrast Transfer In Confocal Microscopy” by R. Oldenbourg, et al.**

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.

Sheet 2 of 2